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P/1596-51

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

New York, New York

Sadao HIRAE et al.

Date: November 1, 2005

Serial No.: 09/751,000

Group Art Unit: 2812

Filed: December 29, 2000

Examiner: Gentle E. Winter

For: SUBSTRATE TREATING METHOD AND APPARATUS

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AMENDMENT/SUBMISSION

Sir:

This is a response to the Office Action mailed August 1, 2005 in the above-identified application. Reconsideration of the application is respectfully requested.

FEE CALCULATION

Any additional fee required has been calculated as follows:

\_\_\_\_\_ If checked, "Small Entity" status is claimed.

NO. CLAIMS AFTER AMENDMENT		HIGHEST NO. PREVIOUSLY PAID FOR		EXTRA PRESENT		RATE		ADDIT. FEE
TOTAL	4	MINUS	32	* =	0	X	(\$9 SE or \$18)	\$0
INDEP.	1	MINUS	8	** =	0	X	(\$42 SE or \$84)	\$0
FIRST PRESENTATION OF MULTIPLE DEPENDENT CLAIM						X	(\$140 SE or \$280)	\$0

\* not less than 20

\*\* not less than 3

TOTAL \$0

If any additional payment is required, a check which includes the calculated fee of \$ \_\_\_\_\_  
(OFGS Check No. \_\_\_\_\_) is attached.